

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Cheung, et al.

Serial No.: 10/648,616

Filed:

August 26, 2003

Confirmation No.: 4378

For:

Plasma Processes For

**Depositing Low Dielectric** 

Constant Films

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Group Art Unit: Unknown

Examiner:

Unknown

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

CERTIFICATE OF MAILING 37 CFR 1.8

I hereby certify that this correspondence is being deposited on 12/12, 2003 with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.

12/12/03

Signature

## SECOND PRELIMINARY AMENDMENT

Prior to examination, please amend the above-identified application as follows. The Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/3032.C6/KMT the fee of \$54.00 for 3 additional claims.

Amendments to the Claims begin on page 2. Remarks begin on page 6.